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IN THE UNITED STATES PATENT AND TRADEMARK OFFICE

In re application of : Confirmation No. 4423
Tomohiro OKUMURA et al. : Docket No. 2001_1089A
Serial No. 09/918,823 : Group Art Unit 2821
Filed August 1, 2001 : Examiner T. Phan

PLASMA PROCESSING METHOD
AND APPARATUS THEREOF

AMENDMENT

Assistant Commissioner for Patents,
Washington, D.C.

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MAR -5 2003
TC 2800 MAIL ROOM
THE COMMISSIONER IS AUTHORIZED
TO CHARGE ANY DEFICIENCY IN THE
FEES FOR THIS PAPER TO DEPOSIT
ACCOUNT NO. 23-0975

Sir:

In response to the Office Action mailed August 28, 2002, a three month extension of time having been obtained, please amend the above-identified application as follows:

IN THE SPECIFICATION:

Please replace the specification with the attached substitute specification.

IN THE ABSTRACT:

Please replace the abstract with the attached substitute abstract.